



Patent  
Attorney's Docket No. 015290-506

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

Ting CHIEN et al.

Application No.: 09/820,692

Filed: March 30, 2001

For: PLASMA ETCHING OF DIELECTRIC LAYER  
WITH SELECTIVITY TO STOP LAYER

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)  
) Group Art Unit: 1765

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) Examiner: K.C. Chen

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) Confirmation No. 5245  
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**AMENDMENT AFTER FINAL REJECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed October 7, 2003, please amend the  
above-identified application as follows:

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FEB 19 2004

*Do not enter.*

*KCC*

*3/4/04*